



UNITED STATES PATENT AND TRADEMARK OFFICE

COMMISSIONER FOR PATENTS
UNITED STATES PATENT AND TRADEMARK OFFICE
P.O. BOX 1450
ALEXANDRIA, VA 22313-1450
www.uspto.gov

Mailed: FEB -2 2004

PJR

Paper No. 10

In re application of
E. Jennings Taylor et al.
Serial No. 09/823,751
Filed: April 3, 2001
For: Pulse Reverse Electrodeposition for
Metallization and Planarization of
Semiconductor Substrates

DECISION ON
PETITION

This is a decision on the PETITION TO WITHDRAW HOLDING OF ABANDONMENT, filed April 21, 2003 for failure to timely respond to the office action dated July 1, 2002.

DECISION

The request is accepted as a petition under 37 C.F.R. 1.181 (no fee). A review of the petitioner's evidence provided with the instant petition indicates that the request does have merit. Submitted as evidence is a copy of the docket records for this application indicating no entry for the office action in question. Further, a copy of applicant's file jacket has been included which also indicates that no office action was received.

Therefore, the Notice of Abandonment dated February 19, 2003 is hereby withdrawn. Hence, the case is returned to pending status. The application shall be returned to the LIE for 1) verification of the correspondence address, 2) remailing the office action and 3) restarting the time period for response to the office action.

The Petition is **GRANTED**.

Jacqueline Stone, Director
Technology Center 1700
Chemical and Materials Engineering

Thompson Hine LLP
2000 Courthouse Plaza NE
10 West Second Street
Dayton, Ohio 45402-1758